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In the United States Patent and Trademark Office

Serial No. PCT/EP2003/003136	§	Date: 26 March 2003
	§	
Title: FORMATION OF THIN SEMI-CONDUCTOR LAYERS BY LOW-ENERGY PLASMA ENHANCED CHEMICAL VAPOR DEPOSITION AND SEMICONDUCTOR HETERO-STRUCTURE DEVICES	§	
	§	Examiner: pending
Applicant: Von Kaenel, Hans	§	GA No.: pending
	§	
Atty docket no: PUS-E006-013	§	

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PRE-AMENDMENT

Via facsimile to 001-571-273-8300, to:
 Commissioner for Patents
 P. O. Box 1450
 Alexandria, Virginia 22313-1450
 U.S.A.

Dear Sir:

Together with the filing of the US national stage application, Applicant requests that the following pre-amendments be entered *before calculation of the fees due therefor*:

In the Claims: